

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/788,806	YU, CHU YIH	
		Examiner	Art Unit	Page 1 of 1
		Gail Verbitsky	2859	

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,133,606	07-1992	Zaragoza et al.	374/208
	B	US-4,765,014	08-1988	Moss et al.	15/229.3
	C	US-2002/0081552	06-2002	Stanwich et al.	433/149
	D	US-5,479,951	01-1996	Denebeim, Sabrina S.	132/265
	E	US-6,637,935	10-2003	Chen, Min-Ying	374/185
	F	US-6,406,182	06-2002	Chen, Min-Ying	374/208
	G	US-5,458,121	10-1995	Harada, Hideo	600/474
	H	US-4,821,417	04-1989	Levine, Anthony H.	30/298
	I	US-5,728,091	03-1998	Payne et al.	606/15
	J	US-4,955,136	09-1990	Diaz-Rivera, Jose E.	30/32
	K	US-5,397,304	03-1995	Truckai, Csaba	604/528
	L	US-2004/0181243	09-2004	Chu et al.	606/144
	M	US-2004/0264546	12-2004	Wong et al.	374/209

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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